L	Hits	Search Text	DB	Time stamp
Number				
1	1	438/20.ccls. and (depth near2 dop\$3)	USPAT;	2004/02/18
			US-PGPUB;	10:02
			EPO; JPO;	
			DERWENT	
2	1	445/\$.ccls. and (depth near2 dop\$3)	USPAT;	2004/02/18
			US-PGPUB;	10:03
			EPO; JPO;	
•			DERWENT	'1
3	4	445/\$.ccls. and (depth near2 implant\$3)	USPAT;	2004/02/18
		-	US-PGPUB;	10:07
			EPO; JPO;	1
			DERWENT	
4	1	(445/\$.ccls. and (depth near2 implant\$3))	USPAT;	2004/02/18
		and boron	US-PGPUB;	10:06
1			EPO; JPO;	
			DERWENT	
5	6195	semiconductor and (boron same (dop\$3	USPAT;	2004/02/18
		implant\$3) same (deep\$2 depth))	US-PGPUB;	10:08
			EPO; JPO;	
			DERWENT	
6	77639	313/\$.ccls. semiconductor and (boron same	USPAT;	2004/02/18
		(dop\$3 implant\$3) same (deep\$2 depth))	US-PGPUB;	10:08
			EPO; JPO;	
İ			DERWENT	
7	35	313/\$.ccls. and semiconductor and (boron	USPAT;	2004/02/18
		same (dop\$3 implant\$3) same (deep\$2	US-PGPUB;	10:14
		depth))	EPO; JPO;	
			DERWENT	
8	6	(313/\$.ccls. and semiconductor and (boron	USPAT;	2004/02/18
		same (dop\$3 implant\$3) same (deep\$2	US-PGPUB;	10:15
		depth))) and (ion near2 bombard\$4)	EPO; JPO;	
			DERWENT	
_	1	975296.apn.	USPAT;	2004/02/18
]	_		US-PGPUB;	10:01
			EPO; JPO;	
			DERWENT	